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**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of

Akifumi KAMIJIMA et al.

Batch/Confirmation No.: 5389

Allowed: 01/27/2005

Group Art Unit: 1756

Application No.: 09/966,080

Examiner: J. Ruggles

Filed: October 1, 2001

Docket No.: 110735

For: METHOD FOR FABRICATING A RESIST PATTERN, A METHOD FOR  
PATTERNING A THIN FILM AND A METHOD FOR MANUFACTURING A  
MICRO DEVICE


**LETTER TO THE OFFICIAL DRAFTSPERSON**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please substitute the attached 1 sheet of formal drawing depicting Figures 13-15 for the corresponding drawing filed with the application. The attached drawing have been corrected pursuant to the Notice re Patent Drawings attached to Paper No./Mail Date 20050111.

Respectfully submitted,

  
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JAO:JWF/ldg

Date: February 28, 2005

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